**YOUNGJIN KIM**

PhD Candidate

Seoul National University, Seoul, South Korea

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| Email | Google scholar | Website | Linkedin |
| [ttw8592@snu.ac.kr](mailto:ttw8592@snu.ac.kr) | [Click here](https://scholar.google.com/citations?user=NZHMHQMAAAAJ&hl=ko&oi=sra) | [Click here](https://youngjin94.github.io/) | [Click here](https://www.linkedin.com/in/youngjin-kim-43b559a3/) |

**EDUCATION**

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| **B.S.** | **Electrical and Computer Engineering**  Seoul National University, Republic of Korea  Advisor: Byung Gook Park (deceased) | 2012. 3 – 2019. 2 |
| **Ph.D.** | **Electrical and Computer Engineering**  Seoul National University, Republic of Korea  Advisor: [Byoungho Lee](https://scholar.google.co.kr/citations?user=VExwDP4AAAAJ&hl=ko) (deceased)  Advisor: [Yoonchan Jeong](http://oeqelab.snu.ac.kr/PROFJ) | 2019.3 – 2025. 2 |
| **Postdoc.** | **Electrical and Computer Engineering**  Seoul National University, Republic of Korea  Advisor: [Yoonchan Jeong](http://oeqelab.snu.ac.kr/PROFJ) | 2025.3 – |

**PROFESSIONAL EXPERIENCE**

**Visiting Researcher** Stanford University, CA, USA2023. 12 – 2024. 2 - Professor: [Mark Brongersma](https://scholar.google.com/citations?user=llkveWIAAAAJ&hl=en&oi=ao), Department of Materials Science and Engineering

**Research Scientist Intern** Meta Reality Labs, WA, USA2024. 6 – 2024. 10 - Department: Optics & Display Research

- Research subject: New waveguide architecture development

**RESEARCH EXPERIENCE**

* **Metasurfaces / Nano-optics**
* Physical understanding of nanostructures’ optical response
* Metasurfaces / Nano-optics design using near-field and far-field simulations
* Hands-on nanofabrication using lithography-techniques
* **Metasurface folded optics (Waveguide)**
* Waveguide-type folded metasurface system design using ray-tracing or wave-optics simulations for ultraslim and integrated imaging system
* Hands-on wafer double-side nanofabrication using lithography-techniques
* **Computational design of optical systems leveraging metasurface optics**
* Joint optimization of metasurface and spatial light modulator (SLM) phase profiles
* End-to-end optimization of metalens imaging system (Hardware + Software co-design)
* Metasurface proxy model design for fully differentiable optimization framework
* Metagrating optimization through rigorous coupled-wave analysis using automatic differentiation
* **Application to Cameras / AR,VR systems / Holographic display / Microscopy**

**HONOR AND AWARDS**

* **Distinguished Dissertation Award**Seoul National University, 2025.
* **Seoul National University Joint International Research Grant**

Seoul National University, 2023.

* **Silver Prize, Samsung Display Industry-Academia Technical Paper Awards**

Samsung Display, 2023.

* **Scholarship of Foundation for SNU ECE - Kim Jung Sik Fund**

Seoul National University, 2021.

* **Best Poster Paper Awards**

Optics and Photonics Congress, Jeju, South Korea, 2021.

**JOURNAL PUBLICATIONS** First Author (4)

† : equal contribution

1. **Y. Kim†**, T. Choi†, G.-Y. Lee, C. Kim, J. Bang, J. Jang, Y. Jeong, and B. Lee, “[Metasurface Folded Lens System for Ultrathin Cameras](https://www.science.org/doi/10.1126/sciadv.adr2319),” **Science Advances**, vol. 10, no. 44, pp. eadr2319, 2024.
2. S.-W. Nam†, **Y. Kim†**, D. Kim, and Y. Jeong, “[Depolarized Holography with Polarization-multiplexing Metasurface](https://arxiv.org/abs/2309.14668),” **ACM Transactions on Graphics (SIGGRAPH Asia),** vol. 42, no. 6, article 200, 2023. (Top 5% in Computer Graphics)
3. **Y. Kim,** G.-Y. Lee, J. Sung, J. Jang, and B. Lee,“[Spiral Metalens for Phase Contrast Imaging](https://onlinelibrary.wiley.com/doi/full/10.1002/adfm.202106050),” **Advanced Functional Materials**, vol. 32, no. 5, pp. 2106050, 2022.
4. Y. Park†, **Y. Kim†,** C. Kim, G.-Y. Lee, H. Choi, T. Choi, Y. Jeong, and B. Lee, “End-to-end Optimization of Metalens for Broadband and Wide-angle Imaging,” **Advanced Optical Materials**, 2402853, 2025 (Early View).

**JOURNAL PUBLICATIONS** Co-Author (6)

1. S.-J. Kim, C. Kim, **Y. Kim**, J. Jeong, S. Choi, W. Han, J. Kim, and B. Lee, “[Dielectric metalens: properties and three-dimensional imaging applications](https://www.mdpi.com/1424-8220/21/13/4584),” **Sensors**, vol. 21, no. 13, pp. 4584, 2021.
2. J. Jang, G.-Y. Lee, **Y. Kim**, C. Kim, Y. Jeong, and B. Lee, “[Dispersion-Engineered Metasurface Doublet Design for Broadband and Wide-Angle Operation in the Visible Range](https://ieeexplore.ieee.org/abstract/document/10163790),” **IEEE Photonics Journal**, vol. 15, no. 4, pp. 1-9, 2023.
3. C. Kim, J. Hong, J. Jang, G.-Y. Lee, **Y. Kim**, Y. Jeong, and B. Lee, “[Freeform Metasurface Color Router for Deep Sub-micron Pixel Image Sensors](https://www.science.org/doi/10.1126/sciadv.adn9000),” **Science Advances**, vol. 10, no. 22, pp. eadn9000, 2024.
4. H. Son, T. Choi, K. Kim, **Y. Kim**, J. Bang, S.-J. Kim, B. Lee, and Y. Jeong, “[Strong Coupling Induced Bound States in the Continuum in a Hybrid Metal–Dielectric Bilayer Nanograting Resonator,](https://pubs.acs.org/doi/abs/10.1021/acsphotonics.4c00602)” **ACS Photonics**, vol. 11, no. 8, pp. 3221-3232, 2024.
5. T. Choi, C. Choi, J. Bang, **Y. Kim**, H. Son, C. Kim, J. Jang, Y. Jeong, and B. Lee, “[Multiwavelength Achromatic Deflector in the Visible Using a Single-Layer Freeform Metasurface](https://pubs.acs.org/doi/full/10.1021/acs.nanolett.4c02995),” **Nano Letters**, vol. 24, no. 35, pp. 10980-10986, 2024.
6. E. Lee, Y. Jo, S.-W. Nam, M. Chae, C. Chun, **Y. Kim**, Y. Jeong, and B. Lee, “[Speckle Reduced Holographic Display System with a Jointly Optimized Rotating Phase Mask](https://opg.optica.org/ol/fulltext.cfm?uri=ol-49-19-5659&id=561014),” **Optics Letters**, vol. 49, no. 19, pp. 5659-5662, 2024.

**CONFERENCES** First Author (5)

1. **Y. Kim**, C. Kim, B. Lee, Y. Jeong, and B. Lee, “Meta-optic Miniaturized Telephoto Lens System,” High Contrast Metastructures XII, SPIE Photonics West 2023, San Francisco, USA, paper 12432-32, Feb. 2023. **(Oral presentation)**
2. **Y. Kim,** C. Kim, and B. Lee, “Phase contrast imaging with multiwavelength achromatic spiral metalens,” OSA Optical Design and Fabrication Congress, Virtual Conference, paper FW4C.3, Jun. 2021. **(Oral presentation)**
3. **Y. Kim**, J. Hong, and B. Lee, “Edge detection metalens with additional spiral phase profiles,” The 20th International Meeting on Information Display (IMID 2020), Virtual Conference, paper 04-10-1232, Aug. 2020. **(Oral presentation)**
4. **Y. Kim,** C. Kim, and B. Lee, “Single-layer edge detecting metalens with combining hyperbolic and spiral phase profiles,” The 14th Pacific Rim Conference on Lasers and Electro-Optics (CLEO PR 2020), Virtual Conference, paper P5-7, Aug. 2020.
5. **Y. Kim**, J. Hong, J. Sung, and B. Lee, “Transmission-Type Color Filters with Silicon Mie Resonators using Guided-Mode-Resonance,” OSA Frontiers in Optics + Laser Science APS/DLS, Washington D.C., USA, paper JW4A.74, Sep. 2019.

**PATENTS**

1. Y. Park, **Y. Kim**, G.-Y. Lee, B. Lee, Y. Jeong, “Double sided metalens and electronic device including the same” (US – Application No. 18/490,121)
2. Y. Jeong, S.-W. Nam, **Y. Kim**, D. Kim, “Holographic display using metasurface and metasurface optimization method” (US – Application No. 18/737,648)

**SKILLS**

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| **Numerical**  **simulations** | **Optical near-field simulations:**  RCWA (Python, Pytorch), FEM (COMSOL Multiphysics), FDTD (Lumerical)  **Optical far-field simulations:**  Ray-optic simulation (Zemax), Wave-optic simulation (MATLAB, Python, Pytorch)  **Computational optics design:**  Data-driven optimization through machine-learning framework (Pytorch), Inverse design of periodic nanostructures using automatic-differentiation (Pytorch)  **Programming languages & tools:**  MATLAB, Python (Pytorch), ZPL (for Zemax) |
| **Experimental**  **experiences** | Optical microscopy, Photography, Holographic display with spatial light modulator, Laser/LED-based experiments |
| **Device fabrication** | **Nanofabrication:**  Focused ion beam (FIB) milling, Electron beam lithography, Photolithography (Aligner, Maskless lithography), Electron beam evaporator, Plasma-enhanced chemical vapor deposition (PECVD), Reactive ion etching (RIE)  **Measurement:**  Scanning electron microscope (SEM), Ellipsometry |
| **Languages** | Korean (Native) / English (Fluent) |

**RESEARCH EXPERIENCE *- Projects***

* **Metalens planar optic system for ultra-slim camera module**

Researcher, Samsung Science & Technology Foundation

Jun. 2020 – July. 2023

* **Improvement of μLED optical characteristics using metasurface technology.**

Researcher, Samsung Display

March. 2021 – Feb. 2023

* **Research for integrated meta-photonics system and its application to mobile real-time 3D imaging**

Researcher, National Research Foundation of Korea

Mar. 2020 - November. 2022

* **Development of virtual reality technology using metasurface optics**

Researcher, Samsung Display

March. 2020 – Feb. 2021